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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/083,684	02/27/2002	Tomonari Yamamoto	020254	1544
38834	7590 05/05/2006		EXAMINER	
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP			ERDEM, FAZLI	
1250 CONNECTICUT AVENUE, NW SUITE 700		ART UNIT	PAPER NUMBER	
WASHINGT	WASHINGTON, DC 20036			-
			DATE MAILED: 05/05/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

	<del></del>	Application No.	Applicant(s)			
Office Action Summary		10/083,684	YAMAMOTO, TOMONARI			
		Examiner	Art Unit			
	-	Fazli Erdem	2826			
	The MAILING DATE of this communication app					
	Period for Reply					
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING DANSIONS of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. The period for reply is specified above, the maximum statutory period verse to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION  36(a). In no event, however, may a reply be solution will expire SIX (6) MONTHS from the application to become ABANDON	ON. timely filed m the mailing date of this communication. NED (35 U.S.C. § 133).			
Status						
2a)⊠	2a) This action is <b>FINAL</b> . 2b) This action is non-final.					
Dispositi	on of Claims	•				
Disposition of Claims						
-	Claim(s) 1-4,6-10,12-14,16-19,21-23 and 25-32 is/are pending in the application.					
_	4a) Of the above claim(s) is/are withdrawn from consideration.					
	☑ Claim(s) <u>1-4,6-10,12-14,16-19,21-23,25 and 26</u> is/are allowed.					
· -	Claim(s) <u>27-32</u> is/are rejected.					
·	Claim(s) is/are objected to.	r clastica requirement	•			
8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
9)☐ The specification is objected to by the Examiner.						
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority u	ınder 35 U.S.C. § 119		•			
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of:						
اره						
	1. Certified copies of the priority documents have been received.					
•	2. Certified copies of the priority documents have been received in Application No					
	3. Copies of the certified copies of the prior		ved in this National Stage			
application from the International Bureau (PCT Rule 17.2(a)).						
* See the attached detailed Office action for a list of the certified copies not received.						
•						
Attachment	t(s) ·					
1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)						
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  5) Notice of Informal Patent Application (PTO-152)						
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date  5) Notice of Informal Patent Application (PTO-152)  6) Other:						

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### **DETAILED ACTION**

## Response to Arguments

1. Applicant's arguments filed 2/3/2006 have been fully considered but they are not persuasive. Both the Esch and Talwar disclose capacitance values that are *more/larger* than 0.25 femtofarads.

# Allowable Subject Matter

1. Claims 1-4, 6-10, 12-14, 16-19, 21-23 25 and 26 allowed.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 27, 28 and 31 rejected under 35 U.S.C. 103(a) as being unpatentable over Talwar et al. (6,380,04) in view of Guegan (5,705,410) further in view of Esch (4,056,825)

Regarding Claims 27, 28 and 31, Talwar et al. disclose a high speed semiconductor transsitor and selective absorption process forming same where in Fig. 1E, shallow source extension 60, shallow drain extension 62, deep source extension 80, deep drain extension 84 are formed under gate structure 36 and in single crystal 10. Source/drain extensions include dopants/impurities for amorphization. Talwar et al. fail to disclose the seeping of source/drain extension under the gate structure with the required capacitance value and the required gate/source overlapping capacitance.

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However, Guegan disclose method of producing a semiconductor with a highly doped zone situated between lightly doped zones for the manufacture of transistors where in Fig. 2, source/drain extensions are under the gate and the required capacitance value is disclosed in column 7. Furthermore, Esch discloses a FET device with reduced gate overlap capacitance of source/drain and method of manufacture where in column 5 and in Fig. 5A, the required gate/source overlap capacitance is disclosed.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required seeping of source/drain under the gate with the required capacitance value and the required gate/source overlapping capacitance in Talwar et al. as taught by Guegan and Esch respectively, in order to have a semiconductor structure with increased performance.

4. Claims 29, 30 and 32 rejected under 35 U.S.C. 103(a) as being unpatentable over Talwar et al. (6,380,04) in view of Guegan (5,705,410) further in view of Zhang (6,855,954)

Regarding Claims 29, 30 and 32, Talwar et al. disclose a high speed semiconductor transsitor and selective absorption process forming same where in Fig. 1E, shallow source extension 60, shallow drain extension 62, deep source extension 80, deep drain extension 84 are formed under gate structure 36 and in single crystal 10. Source/drain extensions include dopants/impurities for amorphization. Talwar et al. fail to disclose the seeping of source/drain extension under the gate structure with the required capacitance value and the required gate/source capacitance overlapping capacitance. However, Guegan disclose method of producing a semiconductor with a highly doped zone situated between lightly doped zones for the manufacture of transistors where in Fig. 2, source/drain extensions are under the gate and the

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required capacitance value is disclosed in column 7. Furthermore, Zhang discloses a thin film transistor, fabrication method thereof and liquid crystal display having the thin film transistor where in Figs. 5 and 6 and in column 8, the required overlapping capacitance between gate and source is disclosed.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required seeping of source/drain under the gate with the required capacitance value, and the he required gate/source overlapping capacitance in Talwar et al. as taught by Guegan and Zhang, respectively in order to have a semiconductor structure with increased performance.

#### Conclusion

5. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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examiner can normally be reached on M - F 8:00 - 5:00.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Fazli Erdem whose telephone number is (571) 272-1914

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Nathan Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

FE April 28, 2006